



Advancements in HF-free bipolar pulsed electropolishing for next-generation superconducting cavities

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Hydrofluoric acid (HF)-free bipolar pulsed electropolishing (BPEP) offers an environmentally sustainable alternative to conventional Buffered Chemical Polishing (BCP) and Electropolishing (EP) techniques for superconducting radiofrequency (SRF) cavities. Recent studies at Jefferson Lab have demonstrated that a single-cell 1.3 GHz niobium cavity processed using HF-free BPEP achieved an accelerating gradient E_{acc} of 35 MV/m with a quality factor Q_0 of $1E10$ at 2 K, following extensive research and optimization. This talk will highlight the challenges encountered in developing this technique, key insights gained from experimental studies, and ongoing efforts to enhance its capabilities. In particular, we will explore its potential for refining Nb₃Sn-coated niobium cavities via vapor diffusion techniques and for electroplating Nb₃Sn films onto various cavity substrates, contributing to the advancement of high-performance SRF systems.

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Footnotes

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Authors: TIAN, Hui (Thomas Jefferson National Accelerator Facility); GENG, Rong-Li (Thomas Jefferson National Accelerator Facility)

Co-author: Dr GE, Mingqi (Thomas Jefferson National Accelerator Facility)

Presenter: GENG, Rong-Li (Thomas Jefferson National Accelerator Facility)

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